

Design with Microprocessors for Mech Engineers

Converting non-periodic to periodic

Expansion into even function OR odd-function

Mechatronics: Electronic Control Systems in Mech Eng

Mechatronics: Electronics in Products & Processes

Mechatronics System Design

Mechatronics: Mechanical System Interfacing

Underdamped system (ζ<1, with 2 complex conjugate roots)

Homogeneous solution

Quantizing: Transformation of continuous analogue input into a set of discrete output states

Coding: Assignment of a digital code word or number of output states

Cutoff frequency, ωc = 1/RC rad/s

Frequency response, M(f) = 1/sqrt(1+(ω/ωc)^2)

Static Sensitivity, K = ΔVout/ΔVin

Lecture 1

Mechatronics Definition

Stiffener: "Science that integrates mechanical devices with electronic controls"

Bolton: "Integration of electronics, control engineering and mechanical engineering"

Bradley, et al: "An integrating theme within the design process [combining] electronic engineering, computing and mechanical engineering"

Shetty & Kolk: "Methodology used for the optimal design of electromechanical products"

Auslander & Kempf: "The application of complex decision making to the operation of physical systems"

Measurement Systems

Transducer: a device to convert a physical quantity into a time varying voltage (called analog signal)

Signal Processor: a device to modify the analog signal

Recorder: a device to display or record the signal.

Gain / Proportional constant

Linearity:

Fundamental freq.:

Fourier Series:

Define:

Then:

Bandwidth & Freq. Response:

Bandwidth ∝ fidelity

bandwidth = ωL to ωH (corner/cut-off freq.)

-3dB comes from

Output amplitude:

F(t) = C1 + Σ (A1 cos(nωt) + B1 sin(nωt))

Underdamped system (ζ<1, with 2 complex conjugate roots)

Homogeneous solution

Quantization Size/Zone Width:

Available in mV

Non-Inverting Amplifier (amplifies input signal without inverting)

Summer Amplifier (add analog signals)

Difference Amplifier (subtract analog signals)

Comparator

Integrator (replace feedback resistor w/ capacitor)

Practical Integrator

Difference amplifier may be satisfactory for low-Z source, but its input Z is too low for high-output impedance source.

Instrumentation Amplifier (subtracting analog signals & non-inverting)

Successive approx. for ADC

Flash ADC

Sigma-Delta ADC

General Solutions for Homogeneous Equation

Linear System

Homogeneous Equation

General Solutions for Linear System

Conversion Time

Aperture Time

Duration of the time window & is associated w any error in the digital output due to changes in the input during this time. The r/s btw the aperture time and the uncertainty in the input amplitude.

ΔV(t) = dv(t)/dt Δt

In general, the time response of a 1st order system is
 $x(t) = a + b e^{-t/\tau}$ where τ is the time constant.

$[C] = [K] \cdot 273.15$
 $[F] = 1.8 \cdot [C] + 32$
**** short circuit $\rightarrow V = 0$**

Sensors

-transducer: convert one form of energy to another

-sensors: produce (electrical) output signal for sensing a physical phenomenon

Classification

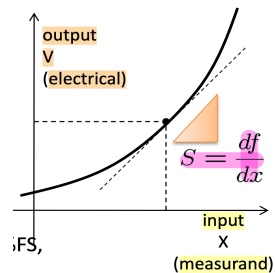
- analog vs digital
- passive (no ext. power, draw from input signal) vs active
- null (deflection due to measured quantity is balanced) vs deflection
- subject of measurement: mechanical, optical, thermal etc.

Instrumentation Systems

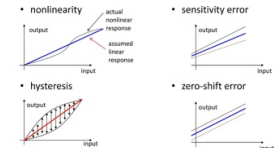
- sensing module: electro + mechanical/thermal/optical/pyro/piezo
- conversion module: analog $\rightarrow$ digital
- pre-processing: variable manipulation module
- data transmission: wired/wireless, over the web
- presentation/storage: to final user

Basic Concepts

$$v_{out} = f(x)$$



-I/O characteristic function/response: input $\rightarrow$ stimulus or measurand (temp, pressure, strain)
 Output $\rightarrow$ electrical signal (voltage, current, freq. phase)
 -sensitivity S: output variation/input variation, $S = df/dx$
 -resolution: minimum change of the measurand that can be reliably detected, limited by noise, bit-conversion
 -accuracy: difference of measurement from true value, %FS, full scale
 -repeatability: how well a system/device can reproduce an outcome in unchanged situation

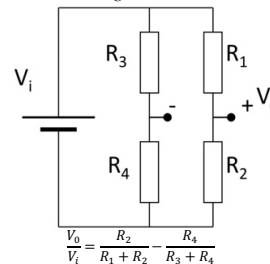


Resistance Temperature Detector (RTD)
 -based on changes of resistance w/ temp.
 -metal wire on insulating support $\rightarrow$ eliminate mechanical strain
 -encasing $\rightarrow$ minimize environment influence
 -linear for limited range:

$$\frac{R}{R_0} = 1 + \alpha(T - T_0)$$

temp. coefficient $\rightarrow$ Platinum $\rightarrow$ $\pm 0.3\%$ over the range 0-200 [C]
 $\rightarrow$ $\pm 1.2\%$ over the range 200-800 [C]

Wheatstone Bridge



$$V_0 = 0 \Leftrightarrow R_1 R_4 = R_2 R_3$$

Thermistors

- ceramic like semiconductors.
- resistance decreases w/ temp.
- high sensitivity, ruggedness, fast time-response

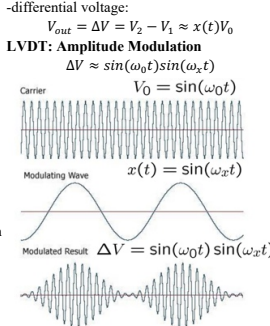
$$R = R_0 e^{\beta(\frac{1}{T} - \frac{1}{T_0})}$$

temp. in KELVIN!!!

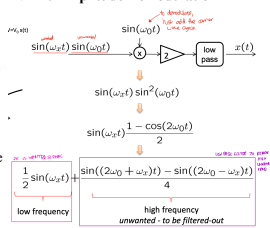
Resistive Sensors (Potentiometer, pot)
 -3 terminal electro-mech. device based on a conductive wiper against fixed resistive element
 -many varieties: rheostats, trimmers, volume control

-precision potentiometers: manually/digitally tuneable
Linear Variable Differential Transformer (LVDT)
 -type of transformer
 -measures linear displacement
 -variable coupling via sliding ferromagnetic core

-differential voltage:
 $V_{out} = \Delta V = V_2 - V_1 \approx x(t) V_0$
LVDT: Amplitude Modulation
 $\Delta V \approx \sin(\omega_0 t) \sin(\omega_x t)$
 $V_0 = \sin(\omega_0 t)$



LVDT: Amplitude Demodulation



Capacitive Sensor (proximity sensor)

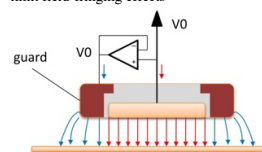
-C=Q/V
 -ideal case: infinite parallel plates

$$\text{Gauss' Law: } Q = \iint_S \epsilon_0 \epsilon_r E dS$$

$$C = \frac{Q}{V} = \frac{\epsilon_0 \epsilon_r S}{d}$$

Guard Electrode

-limit field-fringing effects



AC Interfacing

-AC bridge, AC driving, modulation

Hall Effect

-Lorentz Force:

$$\vec{F} = q \vec{v} \times \vec{B}$$

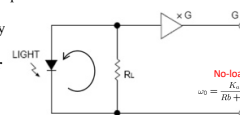
-Lorentz's Law:

$$\vec{F} = (i \times \vec{B}) L \quad F = |i| B L$$

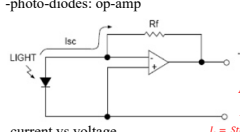
-used for contactless proximity sensor, current sensor $\rightarrow$ Phototransistors

Light Detectors

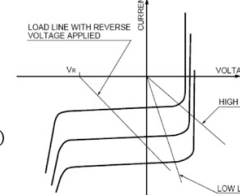
1. Transmissive: photo-interrupter
 2. Reflective: resistive load
 3. Current-voltage op amp
- photo-diodes: load resistance



-photo-diodes: op-amp



-current vs voltage

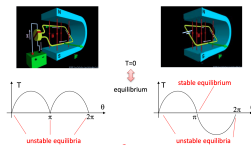


Encoders

-digital encoders: convert motion (linear/rotary) $\rightarrow$ digital pulses (optical transmitter/receiver pairs - glass/plastic material photographically patterned)
 -Hall effect sensors + magnetic rings/bars - incremental encoders w/ 2 Tx/Rx pairs - encoding steps + direction; simple design, needs a 'reset' position
 -absolute encoders n Tx/Rx pairs for coding 2ⁿ sectors; more expensive; spurious states may arise from contemporary transitions solved using gray code as only bit changes every time
 CAVEAT: spurious states may arise from contemporary transitions



• with commutation • without commutation



Motors

-EM induction using LHR:

$$emf = E = - \frac{d\Phi}{dt} \quad \Phi \triangleq \int_S \vec{B} d\vec{S}$$

-Faraday's Law:

emf = electro-motive-force

Φ = magnetic flux

Σ = surface whose boundary coincides w/ the coil

DCM Structure

- stator: external, fixed
- rotor: internal, rotates
- stator and rotor fields always orthogonal $\rightarrow$ maximum torque
- w/ commutation: maintains unstable equilibria $\rightarrow$ constant motion
- w/o commutation: there is a stable equilibria $\rightarrow$ motion ceases
- more poles, more constant torque i.e., independent of rotor positions

Equations

Armature Eqn:

$$V = Ri + L \frac{di}{dt} + e$$

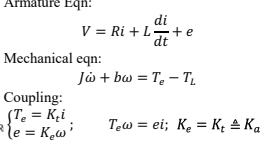
Mechanical eqn:

$$J\omega + b\omega = T_e - T_L$$

Coupling:

$$\begin{cases} T_e = K_t i \\ e = K_e \omega \end{cases} \quad T_e \omega = e i; \quad K_e = K_t \triangleq K_a$$

DCM Speed-Torque Curve



Power: $P_{out} = \omega T_L$
 Armature resistance, $R = \frac{V}{I_a}$
 Armature constant, $K_a = \frac{P_{max}}{I_a}$
 $I_a = \text{Stall current}, T_L = \text{Stall torque}$

Friction load: $T_L = b_L \omega_L$
 Constant torque: $T_L = \text{const.}$
 Inertial: $T_L = I \frac{d\omega}{dt} = 0$

Loads can be a combination of above 3 $\rightarrow$ Efficiency:
 $\eta = \frac{\text{power out}}{\text{power in}} = \frac{\omega T_L}{VI}$

Driving DCM
 -avoid power amp. bcuz large power dissipation + over-heating of amp.
 -continuously switch the motor on and off, Pulse Width Modulation (PWM)
 -DCM is a 2nd order low pass filter

DCM: block-box modeling
 $V = Ri + L \frac{di}{dt} + K_a \omega$
 $J \frac{d\omega}{dt} + b\omega = T_m + K_a i$

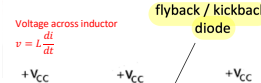
-best materials: constantan, ferrous alloys
 -typical strain ranges S: 1-10⁴ μ S, G: 2
 -challenge: detecting small resistance changes

Transverse Sensitivity
 $dR = R_0 G S$
 $\frac{dR}{R} = \frac{dp}{p} S$

Apparent Strain:
 -combinations of different mechanical loading
 -e.g. beam under bending and axial loading:
 Top of beam: $S_1 = S^a + S^b$
 Bottom of beam: $S_1 = S^a - S^b$

$$G := \frac{dR}{R} = \frac{1}{R} \frac{\partial R}{\partial S} = \frac{dp}{p} \frac{1}{S} + 1 + 2\nu$$

Inductive Kickback



Steady-state I_{on} cannot immediately go to 0 when the switch is opened. Changing current induces a voltage across the inductor, making potential at A > B, causing the switch to blow up. Kickback/flyback diode protects the switch (physical/transistor) from blowing up.

DC Brushless Motors

- stator field rotating
- rotor field given by permanent magnet
- keep rotor and stator field orthogonal to maximize output torque
- detect rotor position via encoders (Hall effect sensors)
- select appropriate switches to determine desired torque

Strain Gauges

-determine safe loading conditions of mechanical structures
Electrical Resistance Strain Gauges
 -thin metal (constantan) foil, patterned onto plastic backing material, bonded onto mech. structures, stress derived using solid mech.

-strain, $S = dL/L$, +ve if tensile, -ve if compressive
 -Poisson's ratio: $\nu = \frac{\text{lateral strain}}{\text{axial strain}} = \frac{\Delta w}{\Delta L}$
 -resistance, $R = \rho \frac{L}{A}$
 -rectangular conductor:
 $\frac{dR}{R} = \frac{dp}{p} + \frac{dL}{L} - \left(\frac{dw}{w} + \frac{dh}{h} \right)$

-axial strain, $S = dL/L$
 -lateral strain:
 $\frac{dw}{w} = \frac{dh}{h} = -\nu \frac{dL}{L} = -\nu S$

Combining above eqns.,
 $\frac{dR}{R} = \frac{dp}{p} + S + 2\nu = \left(\frac{dp}{p} + 1 + 2\nu \right) S$

FYI: piezoresistivity = $\frac{dp}{p} \frac{1}{S}$

Transverse Sensitivity
 $dR = R_0 G S$
 $\frac{dR}{R} = \frac{dp}{p} S$

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 Top of beam: $S_1 = S^a + S^b$
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Integration by Parts
 Choose u in this order: LIATE
 Logs
 Inverse
 Algebraic
 Trig
 Exponential

Wheatstone bridge: 1st order approx.:
 $\frac{dV_0}{V_i} = \frac{1}{4} \left(\frac{dR_2}{R_2} - \frac{dR_1}{R_1} + \frac{dR_3}{R_3} - \frac{dR_4}{R_4} \right)$

Different electrical configuration:
 $\frac{dV_0}{V_i} = \frac{1}{4} G (S_{G1} + S_{G2}) = \frac{1}{2} G (S^a + S^T)$

Quarter-bridge:
 $\frac{dV_0}{V_i} = \frac{1}{4} G (-S_{G1} + S_{G2}) = \frac{1}{2} G S^b$

Half bridge:
 $\frac{dV_0}{V_i} = \frac{1}{4} G (S_{G1} - S_{G2} + S_{G3} - S_{G4}) = G S^b$

How to create a sawtooth input?
 -capacitor
 -microcontroller
 -voltage source

